## Application/Control No. Applicant(s)/Patent Under Reexamination 10/082,228 TATSUURA ET AL. Notice of References Cited Examiner Art Unit Page 1 of 1 Edna Wong 1753 **U.S. PATENT DOCUMENTS** Document Number Date Name Classification Country Code-Number-Kind Code MM-YYYY US-4,217,183 08-1980 Melcher et al. 205/92 US-5,426,686 06-1995 В Rentzepis et al. 378/34 US-С D US-US-Ε US-US-G USн US-US-J US-US-М US-**FOREIGN PATENT DOCUMENTS Document Number** Date Country Name Classification Country Code-Number-Kind Code MM-YYYY Ν 0 Р Q R s **NON-PATENT DOCUMENTS** Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) U V W Х

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